

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 210679US2SRD		SERIAL NO. 09/893,874	
LIST OF REFERENCES CITED BY APPLICANT <div style="position: absolute; top: 100px; left: 100px; border: 1px solid black; border-radius: 50%; padding: 5px; transform: rotate(-45deg);"> OFFICE OCT 11 2005 PATENT & TRADEMARK OFFICE </div>				APPLICANT Hideki KOBAYASHI, et al.			
				FILING DATE June 29, 2001		GROUP 2123	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE	
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
<i>Appl</i>	AO	11-288427	10/19/1999	Japan (with English abstract)		X	
<i>Appl</i>	AP	63-144937	6/17/1988	Japan (with English abstract)		X	
<i>Appl</i>	AQ	11-267951	10/5/1999	Japan (with English abstract)		X	
<i>Appl</i>	AR	11-3101	1/6/1999	Japan (with English abstract)		X	
<i>Appl</i>	AS	5-314094	11/26/1993	Japan (with English abstract)		X	
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	Tomioka et al., "IT Utilization Strategy for Each Product and Attracted Company: Aim at Adoption to Lifetime Reduction, Cost Reduction and Parts Recycle," Nikkei Digital Engineering, Japan, Nikkei Business Publications, Inc., January 15, 2000, No. 26, pp. 104-111.					
	AX	Watanabe et al., "Technique for Recycling Parts of Copying Machine," Nikkei Mechanical, Japan, Nikkei Business Publications Inc., September 8, 1997, No. 514, pp. 22-23.					
	AY	Kimura, "Inverse Manufacturing," IEEE Journal, Japan, The Institute of Electronics, Information and Communication Engineers, August 25, 1997, Vol. 80, No. 8, pp. 791-797.					
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner <i>Appl Shw...</i>				Date Considered <i>10/2/05</i>			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Not
in
English